

Article

MoO₃ Interlayer Modification on the Electronic Structure of Co/BP Interface

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Abstract: The modification by molybdenum trioxide (MoO₃) buffer layer on the electronic structure between Co and black phosphorus (BP) was investigated with ultraviolet photoemission spectroscopy (UPS) and X-ray photoemission spectroscopy (XPS). It was found that the MoO₃ buffer layer could effectively prevent the destruction of the outermost BP lattice during the Co deposition, with the symmetry of the lattice remaining maintained. There is a noticeable interfacial charge transfer in addition to the chemical reaction between Co and MoO₃. The growth pattern of Co deposited onto the MoO₃/BP film is the island growth mode. The observations reveal the significance of a MoO₃ buffer layer on the electronic structure between Co and black phosphorus and provide help for the design of high-performance Co/BP-based spintronic devices.

Keywords: black phosphorus; molybdenum trioxide; Cobalt; buffer layer; photoemission spectroscopy



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1. Introduction

Black phosphorus is a two-dimensional layered puckered material with unique crystal symmetry and has broad application prospects in electrical, optical, energy storage, and other fields [1–5]. In recent years, devices based on BP have emerged continuously, such as field effect transistors [6,7], infrared photodetectors [8–10], thin film solar cells [11,12], polarizers [13], gas sensors [14], etc. BP also has great potential for applications in new spintronic devices. Co is one of the most common ferromagnetic electrodes and is widely used for the injection and detection of spin-polarized currents in devices. Sui et al. applied density functional theory to study the properties of Co atoms adsorbed on BP and found that Co atoms can combine with BP with considerable binding energy [15]. The Co/BP system exhibits interesting magnetic properties due to the cross-splitting of Co 3d orbitals. Kamalakar et al. used TiO₂/Co as the contact electrode of the device to prepare a multilayer BP field effect transistor [16]. The test results showed that there was a magnetoresistance effect in the transistor.

Chirality has attracted a great deal of attention in recent decades for its applications in various disciplines such as polarization optics, spectroscopy, analytical chemistry, and molecular biology. External chirality can be realized in nonchiral anisotropic planar metamaterials, resulting from the mutual orientation of the metamaterial structure and the incident electromagnetic wave. Strong external chirality has been predicted to occur in BP because of its in-plane anisotropy [17].

The breakdown of bulk symmetry at surface and interfaces is of fundamental importance in many areas, including spintronics, ferroics and light–matter interactions. Furthermore, the morphology and electronic structure at the surface and interfaces can add rich physics that requires systematic and meticulous investigations. Although metals are used as electrode materials in many BP-based devices with various functions, the deposition

of metal will usually damage the BP. It finds that there have different influences on the metal/BP interface. There is a reaction between Al and BP [18], and the unique crystal symmetry structure will be destroyed in Co/BP and Au/BP interface [19,20], and so inserting a buffer layer at the interface is necessary. Semiconductor metal oxide thin films are widely used as buffer layer materials. Molybdenum trioxide is a promising semiconductor metal oxide as the active layer of gas sensors and photodetectors [21–25]. Xiang et al. used MoO₃ to modify BP, resulting in a huge hole-doping effect on BP field effect transistors [22]. With the increase of the doping thickness of MoO₃, the conductivity of the BP field effect transistor will be greatly improved.

The effect of MoO₃ buffer layer on the interface electronic structure of Co/BP interface has been studied by UPS and XPS. The results showed that the MoO₃ buffer layer can effectively prevent damage to the BP lattice caused by the metal deposition process. During the deposition process, there is an interfacial interaction between Co and MoO₃. The findings provide guidance for the development of spintronic devices based on Co/MoO₃/BP.

2. Experimental Method

All growth and test were carried out in a set of ultra-high vacuum interconnection systems at room temperature with vacuum pressures better than 1×10^{-9} mbar. In the preparation chamber, the BP crystal was mechanically peeled in a vacuum. Its quality was checked by XPS (SPECS XR-MF, Al K α = 1486.7 eV) in the analysis chamber in order to ensure successful dissociation. UPS was tested by exciting sample with Specs Microwave UV Light Source (He I = 21.22 eV). The hemispherical energy analyzer used for XPS and UPS is SPECS PHPIBOS 150. For XPS measurement, the equipment was calibrated with clean polycrystalline Au. The X-ray source was operated at 100 W with 40 eV pass energy and 100 meV scanning steps for all tests. The XPS spectrum was fitted in detail with CasaXPS. The UPS measurements were performed with a -5 V bias applied to the sample. A total energy resolution was about 70 meV for the UPS as determined from the Fermi edge of clean Au (111). In the experiment, the Co film and MoO₃ film were grown by thermal evaporation, the growth thickness of the film was monitored by quartz crystal microbalance. The sample was transferred through the manipulator of the radial distribution chamber. The transfer step was under ultra-high vacuum environment, preventing sample contamination.

3. Results and Discussion

The crystal structure of BP is shown in Figure 1a, the atomic layers of BP are superimposed by weak van der Waals interaction. The interlayer distance is about 5 Å, and the lattice constants are $a = 3.313$ Å, $b = 4.374$ Å, and $c = 10.473$ Å, respectively [26]. Figure 1c is the XPS full spectrum of BP after dissociation, it can be seen that the P 2s and P 2p peaks of BP are located at 188.4 eV and 130.7 eV, respectively. No impurity peaks such as carbon and oxygen were found, indicating that the clean BP surface was successfully exfoliated. Figure 1b shows the MoO₃ lattice structure, where molybdenum atoms are represented by larger spheres and oxygen atoms are represented by smaller spheres [27]. The cuboid in the figure marks the octahedral MoO₆ cluster, which is the construction unit of MoO₃ crystal, and the lattice constants are $a = 3.962$ Å, $b = 13.855$ Å, $c = 3.699$ Å, respectively. Figure 1d shows the full XPS spectrum after depositing 3 nm MoO₃ on BP. No peaks of P 2s and P 2p were found, indicating that 3 nm MoO₃ would completely cover BP. Our previous research has shown that the growth process of MoO₃ is physical adsorption on BP, and the BP lattice will not be destroyed [18]. The O 1s and Mo 3d_{5/2} peaks are located at 530.5 and 232.7 eV, respectively, which are consistent with the previous test results, indicating that MoO₃ thin films were successfully grown [28].

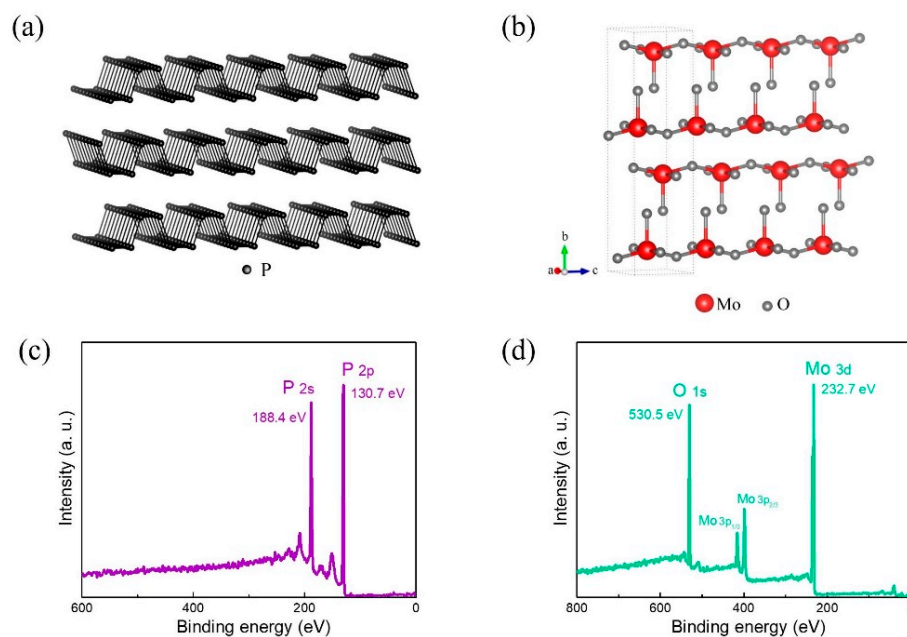


Figure 1. The crystal structure of (a) BP and (b) MoO₃. XPS full spectrum of (c) BP and (d) MoO₃.

Co thin films were grown on MoO₃/BP and Figure 2 shows the UPS spectra as a function of Co film thickness. The work function (WF) is 4.24 eV and 6.33 eV for the intrinsic BP and MoO₃ films, respectively. When 1 Å Co was deposited, the WF decreased to 5.34 eV, and continued to decrease with increasing Co thickness. After depositing 8 Å Co, the WF reaches a minimum of 4.89 eV with a shift of 1.44 eV. As the Co thickness continued to increase, the WF began to increase, and the WF of the Co/MoO₃/BP film was 5.24 eV after 60 Å Co deposition. Figure 2b shows the UPS valence band region, the valence band maximum (VBM) of the intrinsic BP is ~0.1 eV. After depositing 3 nm MoO₃ film, the VBM becomes 2.72 eV. The Fermi level in the figure is marked with a solid line. It can be seen that the Fermi edge of the metal begins to appear when the deposition thickness of Co is 8 Å. In the Co/BP interface, the Fermi edge of the metal begins to appear after the deposition of 4 Å Co. Comparing the UPS data of the Co/MoO₃/BP interface and the Co/BP interface [19], it can be inferred that the chemical reaction between Co and MoO₃ has been averted by inserting the MoO₃ at the Co/BP interface, which delayed the emergence of the Fermi edge of metallic Co.

The XPS spectra as a function of Co thickness when growing Co thin films on MoO₃/BP is shown in Figure 3. When the thickness of Co is 1–4 Å, the Co 2p peak is located at 781.58 eV, corresponding to Cobalt oxide (CoO_x) [29,30]. At 8–15 Å, a new peak appears at 778.75 eV, corresponding to metallic Co. The appearance of CoO_x proves that there is a chemical reaction at the Co/MoO₃ interface. The O 1s and Mo 3d spectra were fitted in detail, the information is in Table S1. Figure 3b shows the fitted O 1s spectrum, the blue peak corresponds to the oxygen component in CoO_x, which is located at 531.45 eV. With the increase of Co thickness, the proportion of oxygen in CoO_x increases gradually. The red peak corresponds to the oxygen component in MoO₃, which is located at 530.51 eV. To further analyze the growth process of Co on MoO₃/BP films, we investigated the attenuation of XPS intensity by the capping layer. The attenuation curve of XPS intensity can be used to analyze the growth mode of the deposit on the substrate [31]. In the Co/MoO₃ interface, the intensity of photoelectrons emitted from Co 2p gradually decreases as the Co thickness increases from 0 to 8 Å. When the thickness is greater than 8 Å, the attenuation of photoelectrons by the Co coating increases significantly, which can be attributed to the island growth of Co. At lower Co coverage ($\Theta < 8$ Å), Co atoms form clusters, which will expose more substrates than the uniformly distributed Co films. Hence the photoelectron intensity decreases slowly at the beginning, corresponding to the smaller

slope shown by the red dashed line in Figure 4b. When the Co covering layer has a sufficient thickness ($\Theta > 8 \text{ \AA}$), the island clusters will be connected to each other to form a continuous covering layer, which will significantly increase the attenuation of photoelectrons. The corresponding slope also becomes larger. Therefore, it can be inferred that the growth mode of Co deposition on MoO₃/BP films is island growth.

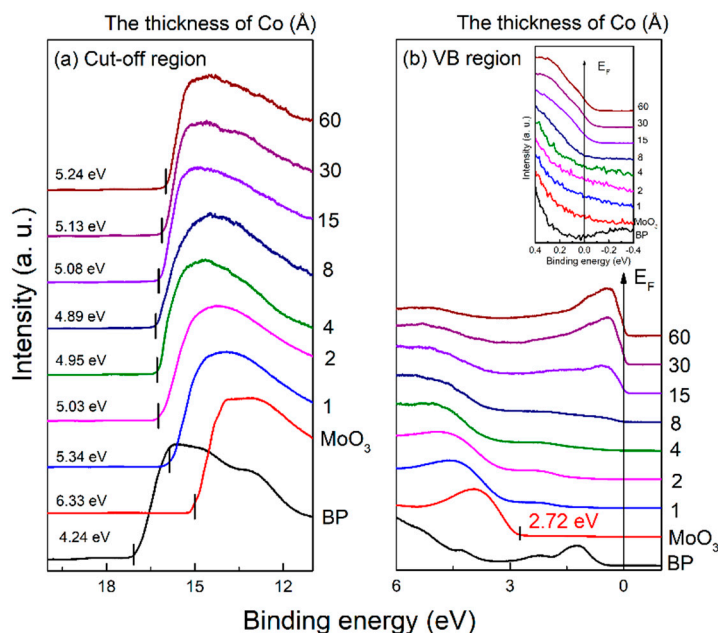


Figure 2. UPS spectra as a function of Co film thickness when growing Co thin films on MoO₃/BP, (a) cut-off region, (b) VB region, Inset: the locally enlarged view of the VB edge region near E_F.

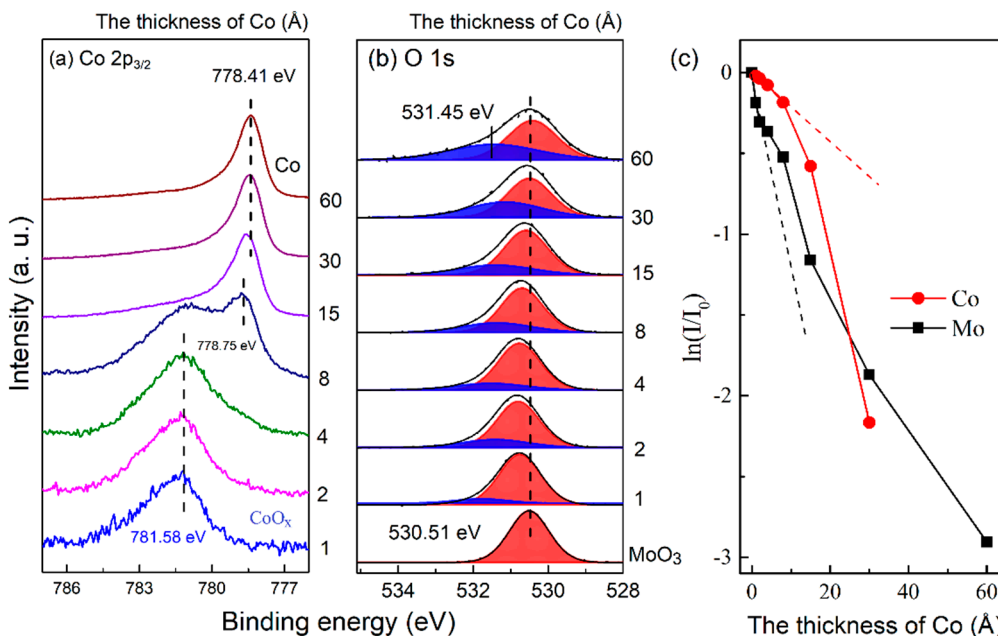


Figure 3. XPS spectra as a function of Co film thickness when growing Co thin films on MoO₃/BP. (a) Co 2p, (b) O 1s, the blue (red) peak corresponds to the oxygen component in CoO_x (MoO₃). (c) Photoelectron intensity as a function of Co film thickness. The red (black) dashed line marks the slope of Co 2p (Mo 3d) before Co deposition to 8 Å.

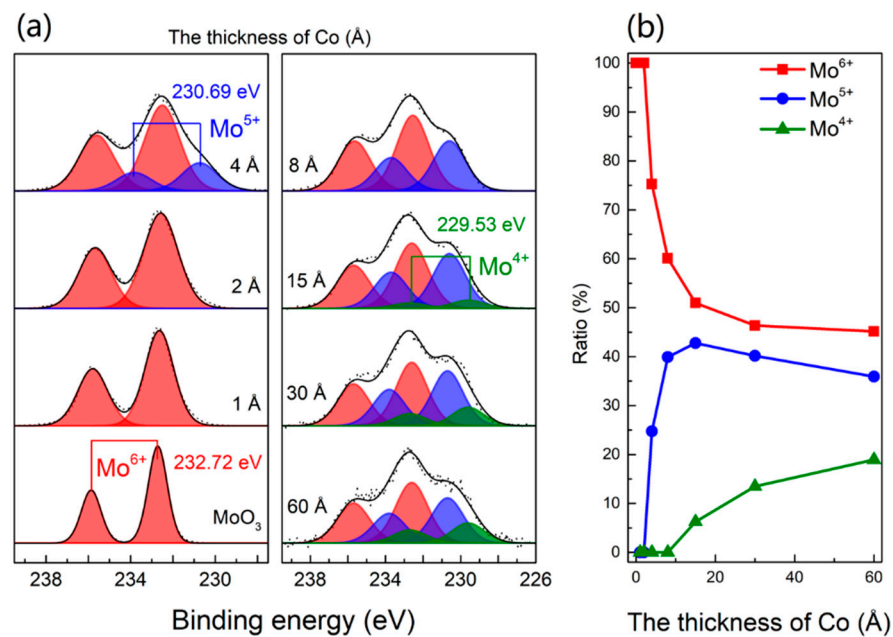


Figure 4. (a) Mo 3d spectra as a function of Co film thickness when growing Co thin films on MoO₃/BP. The red, blue, and green peaks are represented as Mo⁶⁺, Mo⁵⁺, Mo⁴⁺ oxidation states, respectively. (b) The proportion of different oxidation states of Mo varies with Co thickness.

The Mo 3d spectra as a function of Co film thickness when Co thin films deposition on MoO₃/BP is shown in Figure 4a. The Mo 3d peak consists of Mo 3d_{3/2} and Mo 3d_{5/2}, for simplicity, here only discusses the Mo 3d_{5/2} peak. The different color peaks correspond to different oxidation states of Mo, the red, blue, and green peaks are represented as Mo⁶⁺, Mo⁵⁺, and Mo⁴⁺, respectively. Their corresponding binding energies are, respectively, located at 232.72 eV, 230.69 eV, and 229.53 eV. In intrinsic MoO₃, the oxidation state of Mo is Mo⁶⁺. The Mo⁵⁺ oxidation state appears when the deposition thickness of Co is 4 Å, and the Mo⁴⁺ oxidation state appears at 15 Å. The proportion of different oxidation states of Mo varies with Co thickness as shown in Figure 4b. From 1 to 15 Å, the proportion of the Mo⁶⁺ oxidation state decreases monotonously from 100% to 50%. The Mo⁵⁺ oxidation state first increases and then decreases with the increase of Co thickness, reaching a maximum value of 43% at 15 Å. The Mo⁴⁺ oxidation state increases monotonically with the Co thickness, and the proportion of the Mo⁴⁺ oxidation state increases to 18% at 60 Å. It can be inferred that the oxidation state of Mo⁴⁺ is mainly reduced from Mo⁵⁺.

Figure 5 is the energy level diagram of the Co/MoO₃/BP interface derived from the test data. The WF of the intrinsic BP is 4.24 eV, and the VBM is 0.1 eV. Since the band gap of BP is 0.3 eV, it can be deduced that the conduction band maximum (CBM) is 0.2 eV. The WF of MoO₃ is 6.33 eV and the VBM is 2.72 eV. Since the band gap of MoO₃ is 3.1 eV, the CBM can be deduced to be 0.38 eV. The interface dipole corresponds to the difference between the vacuum levels when the fermi level is the reference energy level, it is found that there is an interface dipole of 2.09 eV at the MoO₃/BP interface, which is oriented from MoO₃ to BP substrate. With the deposition of Co, a chemical reaction occurs at the interface, and MoO₃ is reduced while the WF begins to decrease. After depositing 60 Å of Co, the WF of the sample is 5.24 eV. Since electrons are transferred from Co film to MoO₃, there is an interface dipole from MoO₃ to Co film at the interface, which is 1.09 eV.

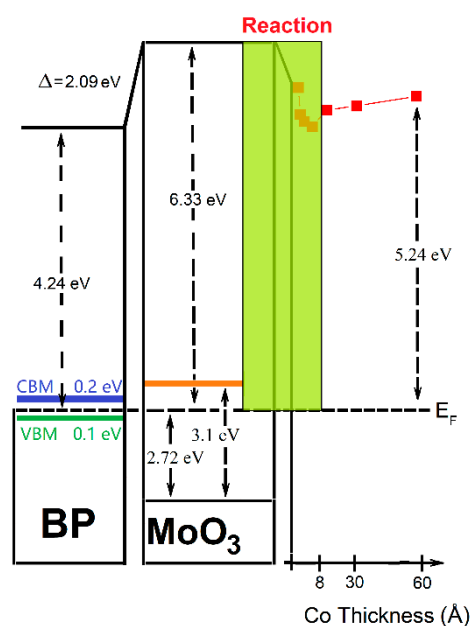


Figure 5. An energy level diagram of the Co/MoO₃/BP interface.

4. Conclusions

In conclusion, the electronic structure of the Co/MoO₃/BP interface was investigated using photoelectron spectroscopy. It was found that a reaction occurred between Co and MoO₃ in the initial deposition stage of Co. Adding a MoO₃ buffer layer between Co and BP effectively prevented the damage to the black phosphorus lattice caused by Co deposition. There was also an interface dipole of 1.09 eV at the Co/MoO₃ interface, and the direction is from MoO₃ to Co film. These research results provide help for the development of spintronic devices based on Co/MoO₃/BP.

Supplementary Materials: The following supporting information can be downloaded at: <https://www.mdpi.com/article/10.3390/sym14112448/s1>, Table S1: Peak positions and FWHM values of XPS spectra.

Author Contributions: Conceptualization, H.X.; methodology, B.L. and H.X.; software, B.L.; validation, B.L., H.X. and Y.Z.; formal analysis, B.L.; investigation, B.L.; resources, H.X. and D.N.; data curation, B.L.; writing—original draft preparation, B.L.; writing—review and editing, H.X., D.N., and Y.G.; visualization, B.L.; supervision, H.X. and Y.G.; project administration, H.X.; funding acquisition, H.X., D.N. and Y.G. All authors have read and agreed to the published version of the manuscript.

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Data Availability Statement: The data presented in this study are available on request from the corresponding author.

Conflicts of Interest: The authors declare no conflict of interest.

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